



# IN THE UNITED STATES PATENT AND TRADEMARK OFFICE?

## In re Application of:

Vernon M. Williams

Serial No.: 09/511,986

Filed: February 24, 2000

For: STEREOLITHOGRAPHICALLY

FABRICATED CONDUCTIVE

ELEMENTS, SEMICONDUCTOR DEVICE

COMPONENTS AND ASSEMBLIES INCLUDING SUCH CONDUCTIVE

ELEMENTS, AND METHODS

Confirmation No.: 6129

Examiner: O. Nadav

Group Art Unit: 2811

Attorney Docket No.: 4208US

(99-0316.00/US)

#### CERTIFICATE OF MAILING

I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents, Washington, D.C. 20231.

January 29, 2003

Deidra Pfeil
Name (Type/Print)

### SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Box NON-FEE Commissioner for Patents Washington, D.C. 20231

Sir:

In compliance with the duty to disclose information material to patentability pursuant to 37 C.F.R. § 1.56, it is respectfully requested that this Supplemental Information Disclosure Statement be entered and the documents listed on attached Form PTO/SB/08 be considered by the Examiner and made of record. Copies of the listed documents are enclosed pursuant to 37 C.F.R. § 1.98(a).

In accordance with 37 C.F.R. § 1.97(g) and (h), filing of this Supplemental Information Disclosure Statement is not to be construed as a representation that a search has been made or an admission that the information cited herein is, or is considered to be, material to patentability as defined in 37 C.F.R. § 1.56(b). Further, no representation is made by Applicant herein that no other possible material information as defined in 37 C.F.R. § 1.56 (b) exists.

#### U.S. Patent Documents

U.S. Patent No.	<b>Publication Date</b>	<u>Patentee</u>
US - 6,251,488 B1	06/26/2001	Miller et al.

#### Other Documents

Miller, Doyle, "New Laser-Directed Technology," HDI, p. 16 (August 2001).

Miller, Doyle, et al., "Maskless Mesoscale Materials Deposition," HDI, pp. 20-22 (September 2001).

Applicant offers to supply any explanation or discussion of the documents which the Examiner feels is necessary or desirable and which is requested.

This Supplemental Information Disclosure Statement is filed after the mailing date of the first Office Action on the merits.

I hereby certify that no item of information contained in the Supplemental Information

Disclosure Statement was first cited in any communication from a foreign patent office in a

counterpart foreign application or, to the knowledge of the undersigned after making reasonable

inquiry, was known to any individual designated in 37 C.F.R. § 1.56(c) more than three months prior to the filing of the statement, and therefore no fee is due.

Respectfully submitted,

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Date: January 29, 2003

BGP/jml:djp

Enclosures: Form PTO/SB/08

Copy of documents cited

Document in ProLaw